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In re Application of:

Yoshikazu MIYAJIMA et al.

Application No.: 10/820,120

Filed: April 8, 2004

For: STAGE APPARATUS, EXPOSURE  
SYSTEM USING THE SAME, AND  
DEVICE MANUFACTURING METHOD

03560.003451

Examiner: K. C. Gutierrez

Group Art Unit: 2851

Confirmation No.: 8660

July 18, 2006

**Mail Stop AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Amendment After Final Action in the above-identified application.

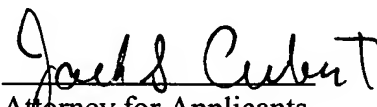
☒ No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	12	MINUS	20	0	x \$25 \$50	\$0.00
INDEP. CLAIMS	2	MINUS	4	0	x \$100 \$200	\$0.00
Fee for Multiple Dependent claims \$180/\$360						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$0.00

- ☐ Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☐ A check in the amount of \$\_\_\_\_\_ is enclosed to cover the additional claims fee.
- ☐ Charge \$\_\_\_\_ to Deposit Account No. 06-1205.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. § 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. §§ 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205.
- ☐ A check in the amount of \$\_\_\_\_\_ to cover the extension fee for response within one additional month is enclosed.
- ☐ A check in the amount of \$\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
Attorney for Applicants  
Jack S. Cubert  
Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO  
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New York, New York 10112-3800  
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JSC/cmg

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BOX AF  
RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINER GROUP 2851

03560.003451

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
Yoshikazu MIYAJIMA et al.	)	Examiner: Kevin C. Gutierrez
Application No.: 10/820,120	)	Group Art Unit: 2851
Filed: April 8, 2004	)	Confirmation No.: 8660
For: STAGE APPARATUS, EXPOSURE SYSTEM	)	July 18, 2006
USING THE SAME, AND DEVICE	)	
MANUFACTURING METHOD	)	

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL ACTION

Sir:

In response to the Official Action dated April 28, 2006, please amend the above-identified application as follows: